

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 5, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG750567666

LABORATORY GROWN DIAMOND

EMERALD CUT

8.30 X 5.93 X 4.04 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.02 CARATS

E

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

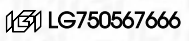
EXCELLENT

EXCELLENT

NONE

Inscription(s)

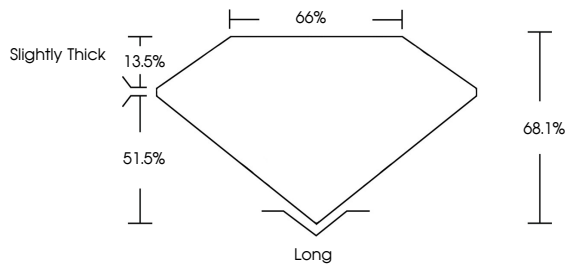
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



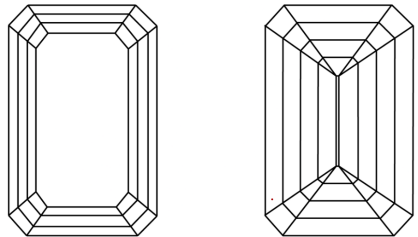
LG750567666

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless



Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included


Included



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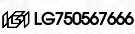
EXCELLENT


EXCELLENT

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IGI

December 5, 2025

IGI Report No LG750567666

EMERALD CUT

8.30 X 5.93 X 4.04 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Slightly Thick

Long

Polish

Symmetry

Fluorescence

Inscription(s)

2.02 CARATS

E

VVS 1

68.1%

65%

EXCELLENT

EXCELLENT

NONE

IGI LG750567666

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